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2823 174

AMENDMENT TRANSMITTAL LETTER				Docket No. 8733.307.00-US	
Application No. 09/709,483 - Conf. #4557		Filing Date November 13, 2000		Examiner Thanh V. Pham	
				Art Unit 2823	
Applicant(s): Oh-Nam KWON					
Invention: METHOD OF MANUFACTURING A THIN FILM TRANSISTOR					
TO THE COMMISSIONER FOR PATENTS					
Enclosed herewith is an Amendment and Response to Final Office Action in the referenced application. The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	13	- 20 =	0	x	
Independent Claims	1	- 3 =	0	x	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this Amendment and Response to Final Office Action.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>50-0911</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 George G. Ballas Attorney Reg. No.: 52,587				Dated: <u>April 28, 2006</u>	



Docket No.: 8733.307.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Oh-Nam KWON

Customer No.: 30827

Application No.: 09/709,483

Confirmation No.: 4557

Filed: November 13, 2000

Art Unit: 2823

For: METHOD OF MANUFACTURING A THIN
FILM TRANSISTOR

Examiner: Thanh V. Pham

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated February 3, 2006, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.